

10/019809

25 OCT 2001  
PATENT  
450104-03688

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s) : ESASHI Masayoshi, et al  
Int'l Appln. No. : PCT/JP00/02739  
Int'l Filing Date : April 27, 2000  
Title of Invention : METHOD OF MANUFACTURING A  
MICROMACHINE

745 Fifth Avenue  
New York, NY 10151

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**INFORMATION DISCLOSURE STATEMENT**

Assistant Commissioner for Patents  
Washington, D.C. 20231

Dear Sir:

Enclosed are copies of the publications, which were cited in the International Search Report of International Application No. PCT/JP00/02739. Also enclosed is a copy of Form PTO-1449 and the International Search Report.

PATENT

450104-03688

30 3 1997 25 OCT 1997

REMARKS

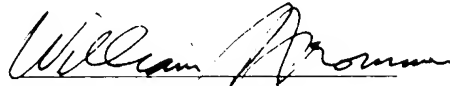
Entry of this Information Disclosure Statement and an early examination on the merits are respectfully solicited.

Please charge any additional fees to Deposit Account No. 50-0320.

Respectfully submitted,

FROMMER LAWRENCE & HAUG LLP

By:



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WSF/ yrp  
Enclosures

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3 Rev 0 PCT/JP 25 OCT 2001  
Sheet 1 of 1

Based on Form PTO-1449 (3-99)  LIST OF REFERENCES CITED BY APPLICANT (Use several sheets if necessary)				ATTY DOCKET NO.  450104-03688		SERIAL NO.		
				APPLICANT  ESASHI Masayoshi, et al				
				FILING DATE  Filed Concurrently		GROUP		
U.S. PATENT DOCUMENTS								
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
	AA	5,955,776	09 21 99	Ishikaa				
	AB							
	AC							
	AD							
	AE							
	AF							
	AG							
	AH							
	AI							
	AJ							
FOREIGN PATENT DOCUMENTS								
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
	AK	9-288124	11 04 97	Japan				
	AL	10-96741	04 14 98	Japan				
	AM	10-154820	06 09 98	Japan				
	AN	10-313139	11 24 98	Japan				
	AO	6-335265	12 02 94	Japan				
	AP	98 25090	06 11 98	WIPO				
	AQ	1239543	12 22 99	China				
	AR	360909	06 11 99	Taiwan				
	AS							
OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)								
	AI		Norio Takeda et. al., "Ball Semiconductor Gijutsu to MEMS sensor e no Oyo", IEEEJ Kenkyukai Shiryou, SMP 99-5-9, 23 July 1999, pp. 1-6					
	AU		Masaki Yamashita et. al., "Kyumen Handoutai no Kangae Kata to Sono Kaihatsu Jokyo", Denshi Zairyo, vol. 37, no. 11, 1998, pp. 21-26					
EXAMINER				DATE CONSIDERED				
<p>* EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</p>								